

Answer 1

**Bibliographic Information**

**Positive-type photoresist composition with low toxicity.** Yoshimoto, Hiroshi; Suzuki, Nobuo. (Fuji Photo Film Co., Ltd., Japan). J Kokai Tokkyo Koho (1997), 13 pp. CODEN: JKXXAF JP 09244231 A2 19970919 Heisei. Patent written in Japanese.  
 Application: IP 96-52008 19960308 CAN 127-301274 AN 1997-619206 CAPLUS (Copyright 2003 ACS)

**Patent Family Information**

Patent No	Kind	Date	Application No	Date
IP 09244231	A2	19970919	IP 1996-52008	19960308

**Priority Application**

IP 1996-52008	19960308
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**Abstract**

The compn. has (A) an alk.-sol. resin, (B) 1,2-naphthoquinonediazide-4-sulfonate and/or 1,2-naphthoquinonediazide-5-sulfonate, and (C) alkoxybutylacetate and/or alkoxypropylacetate. The compn. is useful for manufg. a semiconductor device, a liq. crystal, a printed circuit board etc. The compn. shows low toxicity, storage stability, good application property, high resolu., low striation, and heat resistance.

**Patent Classifications**

**Main IPC:** G03F007-004 **Secondary IPC:** G03F007-022; H01L021-027

**Indexing** -- Section 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

**Phenolic resins: uses**

Role: DEV (Device component use); USES (Uses)

(novolak: pos.-type photoresist compn. contg. alkoxybutylacetate and/or alkoxypropylacetate with low toxicity)

**Photoresists**

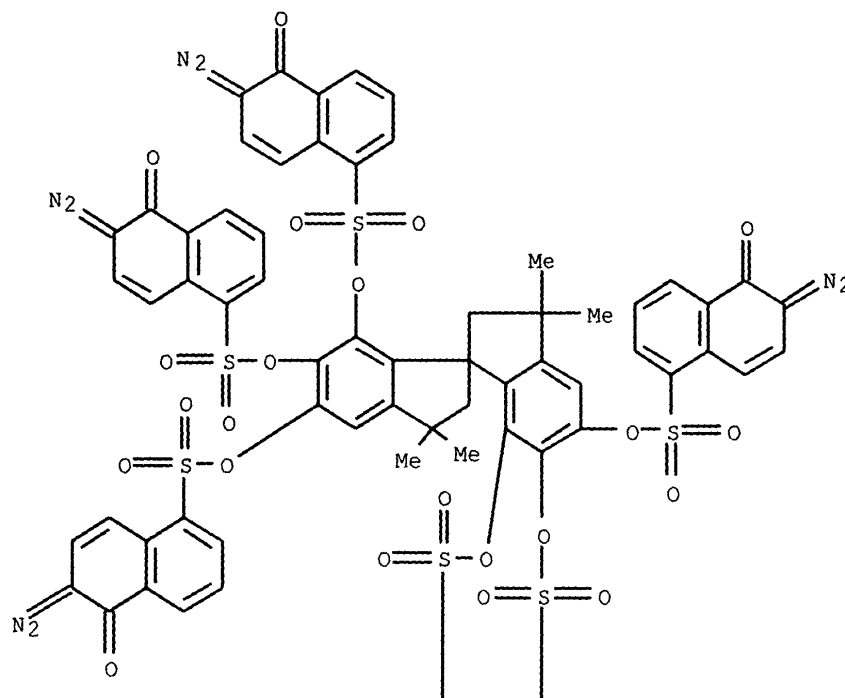
(pos.-type: pos.-type photoresist compn. contg. alkoxybutylacetate and/or alkoxypropylacetate with low toxicity)

68510-93-0

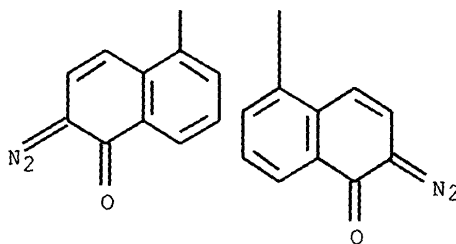
107761-81-9 2,3,4,4'-Tetrahydroxybenzophenone 1,2-naphthoquinonediazide-5-sulfonate

136830-78-9

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143213-15-4

168634-43-3

197220-63-6

197220-66-9

Role: DEV (Device component use); USES (Uses)

(pos.-type photoresist compn. contg. alkoxybutylacetate and/or alkoxypropylacetate with low toxicity)

27029-76-1P, m-Cresol-p-cresol-formaldehyde copolymer

Role: DEV (Device component use); IMF (Industrial manufacture); PREP (Preparation); USES (Uses)

(pos.-type photoresist compn. contg. alkoxybutylacetate and/or alkoxypropylacetate with low toxicity)

4435-53-4, 3-Methoxybutylacetate

103429-90-9, 3-Methoxy-3-methylbutylacetate

Role: DEV (Device component use); MOA (Modifier or additive use); USES (Uses)

(pos.-type photoresist compn. contg. alkoxybutylacetate and/or alkoxybutylacetate with low toxicity)

**Supplementary Terms**

photoresist pos type alkoxybutylacetate alkoxybutylacetate; naphthoquinonediazide sulfonate toxicity free photoresist